

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s) : Franz LAERMER
Serial No. : 10/519,724
Filed : December 28, 2004
For : DEVICE AND METHOD FOR THE PRODUCTION OF
CHLORINE TRIFLUORIDE AND SYSTEM FOR
ETCHING SEMICONDUCTOR SUBSTRATES USING
THIS DEVICE
Examiner : Rakesh Dhingra
Art Unit : 1792
Confirmation No. : 5180

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

RESPONSE

S I R:

This paper is filed in response to the Office Action of June 16, 2008 in connection with the above-captioned application.

Remarks begin on page 2 of this paper.